

1741

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Ryushin Omasa

Serial No.: 09/864,650 ✓

Group:

Filed: May 23, 2001

Examiner: unknown

For: ELECTROPLATING METHOD USING COMBINATION OF
VIBRATIONAL FLOW IN PLATING BATH AND PLATING
CURRENT OF PULSE

#3
AS
8/22/02

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INFORMATION DISCLOSURE STATEMENT

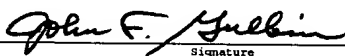
Commissioner for Patents
Washington, D.C. 20231

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S I R :

In accordance with the Applicant's continuing obligation to bring to the attention of the Patent and Trademark Office all references coming to his attention which are related to the invention of the subject application, Applicant hereby directs the Office's attention to the following references, copies of which are being submitted herewith. Form PTO-1449 listing the references is also enclosed.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed: Assistant Commissioner for Patents, Washington, D.C. 20231, on August 12, 2002
John F. Gulbin


Signature

August 12, 2002
Date of Signature

The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Account No. 50-1145.



Foreign Patent Documents

JP 63 312996
(12/21/88)

JP 62 235714
(19/15/87)

JP 02 030790
(2/1/90)

DE 4322378
(12/1/95)

EP 0 950728 A2
(10/20/99)

The preceding references are mentioned in the search report of the corresponding Singapore application.

The Applicant is of opinion that the present invention is patentable over these references. They are being submitted to the Patent and Trademark Office to ensure that all pertinent art of which the Applicant is aware is before the Examiner for consideration. Entry of these references into the file of the present application is believed to be in order and is respectfully requested.

Respectfully submitted,

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